

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN THE MATTER OF: EUN, et al
SERIAL NO: 10/539,886
FILED: June 17, 2005
TITLE: METHOD FOR PREPARING FILM STRUCTURE
COMPRISING
FERROELECTRIC SINGLE CRYSTAL
LAYER
GROUP: 1791
CONFIRMATION NO: 1951
EXAMINER: Sonya MAZUMDAR

AMENDMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

MAIL STOP: AMENDMENT

SIR:

This is in response to the outstanding office communication dated March 17, 2008. Applicant respectfully requests that any insufficient fees be deducted from our deposit account 504581.

Please amend the application as follows: